

Application Data Sheet**Application Information**

Application Type::	Regular
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD OF MANUFACTURING RESIN INSULATING LAYER, SUBSTRATE FOR ELECTRIC OPTICAL APPARATUS, METHOD OF MANUFACTURING ELECTRIC OPTICAL APPARATUS, AND ELECTRIC OPTICAL APPARATUS
Attorney Docket Number::	116741
Total Drawing Sheets::	10
Small Entity::	No

Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hiroshi
Family Name::	SERA
City of Residence::	Suwa-shi
Country of Residence::	Japan

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Yoshiki
Family Name::	NAKASHIMA
City of Residence::	Suwa-shi
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2002-248984	08/28/2002	Yes
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-199929	07/22/2003	Yes
Assignee Information			
Assignee Name::		SEIKO EPSON CORPORATION	
Street of mailing address::		4-1, Nishishinjuku 2-chome, Shinjuku-ku	
City of mailing address::		Tokyo	
State or Province of mailing address::			
Country of mailing address::		Japan	
Postal or Zip Code of mailing address::		163-0811	